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ELECTRONIC CIRCUIT DEVICE

Background of the Invention

5 The present invention relates to an
electronic circuit device having an electronic circuit
element, a substrate including a front surface on which
the electronic circuit element is mounted and a reverse
surface opposite to the front surface in a thickness
10 direction of the substrate, an electrically conductive
terminal member electrically connected to the
electronic circuit element, a lead frame extending
perpendicular to the thickness direction to face the
reverse surface in the thickness direction, and a
15 sealing resin covering at least partially the
electronic circuit element, substrate and lead frame
while at least a part of the electrically conductive
terminal member is prevented from being covered by the
sealing resin.

20 In a prior art electronic circuit device as
disclosed by "Effect of Lead Frame Material on Plastic-
Encapsulated IC Package Cracking Under Temperature
Cycling" (writers : Asao Nishimura, Sueo Kawai and Gen
Murakami, included by IEE TRANSACTIONS ON COMPONENTS,
25 HYBRIDS, AND MANUFACTURING TECHNOLOGY, VOL. 12, NO. 4,
pp639-645 published in December 1989), JP-A-9-232341
and JP-A-2000-183241, an electronic circuit element and
a metallic lead frame are joined with each other and

encapsulated monolithically with a resin, for example, epoxy resin.

Brief Summary of the Invention

An object of the present invention is to
5 provide an electronic circuit device in which a break
between a resin and a lead frame and/or a crack of the
resin on an end of the lead frame is restrained.

In an electronic circuit device comprising,
an electronic circuit element, a substrate including a
10 front surface on which the electronic circuit element
is mounted and a reverse surface opposite to the front
surface in a thickness direction of the substrate, an
electrically conductive terminal member electrically
connected to the electronic circuit element, a lead
15 frame extending perpendicular to the thickness
direction to face the reverse surface in the thickness
direction through an adhesive, and a sealing resin
covering at least partially the electronic circuit
element, substrate and lead frame while at least a part
20 of the electrically conductive terminal member is
prevented from being covered by the sealing resin,

according to the present invention, in a
cross sectional view taken along an imaginary plane
passing the substrate and lead frame and extending
25 parallel to the thickness direction, the substrate
extends to project outward with respect to an end of
the lead frame in a transverse direction perpendicular

to the thickness direction while the end of the lead frame is covered by the sealing resin.

Since the substrate extends to project outward with respect to an end of the lead frame in a transverse direction perpendicular to the thickness direction while the end of the lead frame is covered by the sealing resin, a concentration of shearing stress between the resin and lead frame at the end of the lead frame is decreased so that an occurrence of a break between the lead frame and resin and/or a crack of the resin on the end of the lead frame is restrained.

The above structural distinctive feature is particularly effective for restraining the occurrence of a break between the lead frame and resin and/or the crack of the resin on the end of the lead frame in case of that a coefficient of linear expansion of the lead frame in the transverse direction is smaller than a coefficient of linear expansion of the sealing resin, that a difference in coefficient of linear expansion in the transverse direction between the substrate and the lead frame is smaller than a difference in coefficient of linear expansion in the transverse direction between the sealing resin and the lead frame, that the electronic circuit device further comprises a resin adhesive through which the lead frame is adhered to the reverse surface, that the lead frame is prevented from being formed on the substrate through a deposition process on the reverse surface (the deposition process

includes at least one of spattering and plating), that the end of the lead frame is formed by a shearing process, and/or that the end of the lead frame is formed by an etching process.

5 The above structural distinctive feature is preferably applicable to a case of that the imaginary plane extends parallel to a longitudinal direction of the part of the electrically conductive terminal member, that the electronic circuit device comprises a
10 plurality of the electrically conductive terminal members juxtaposed in an electrically conductive terminal member array direction, and the imaginary plane extends perpendicular to the electrically conductive terminal member array direction, and/or that
15 the lead frame is formed in one-piece (so that the electronic circuit device comprises the single lead frame), a part of the lead frame in one-piece is prevented from being covered by the sealing resin to protrude from the sealing resin in a protruding
20 direction perpendicular to the thickness and transverse directions, and the imaginary plane extends perpendicular to the protruding direction (in this case, the lead frame may have a surface facing to the reverse surface in the thickness direction and
25 prevented from being covered by the sealing resin to protrude from the sealing resin in the protruding direction).

It is preferable that in the cross sectional

view, the substrate extends to project outward in the transverse direction with respect to another end of the lead frame opposite to the end of the lead frame in the transverse direction if the another end of the lead
5 frame is covered by the sealing resin. It is preferable that a part of the lead frame is prevented from being covered by the sealing resin to protrude from the sealing resin in a protruding direction perpendicular to the thickness and transverse
10 directions, and a width between the another end and the end in the cross sectional view perpendicular is smaller than a width of the part of the lead frame in the transverse direction. It is preferable for securely preventing the occurrence of a break between
15 the lead frame and resin and/or the crack of the resin on the end of the lead frame that in the cross sectional view, a width of the lead frame between the another end and the end is not more than 80 % of a width of the substrate.

20 The above structural distinctive feature is preferably applicable to a case of that the electronic circuit element includes a semiconductor body whose main component is a semiconductor, and as seen in the thickness direction, the semiconductor body and the
25 lead frame overlap with each other. In this case, the electronic circuit element may include at least one of a central processing unit and a power transistor, and/or as seen in the thickness direction, the whole of

the semiconductor body may overlap with the lead frame.

It is preferable that the lead frame is prevented from being electrically connected to the electronic circuit element so that a heat energy is
5 prevented from being generated by an electric power passing through the lead frame.

The present invention is particularly preferably applicable to a case of that the lead frame is metallic, and a main component of the substrate is a
10 ceramic.

Brief Description of the Several Views of the Drawings

Fig. 1 is a lower view of an electronic circuit device as a first embodiment of the invention.

Fig. 2 is a cross sectional front view of the
15 electronic circuit device taken along a line II-II in Fig. 1.

Fig. 3 is a partially cross sectional upper view of the electronic circuit device as the first embodiment.

20 Fig. 4 is a partially cross sectional front view of the electronic circuit device as the first embodiment of the invention.

Fig. 5 is a partially cross sectional side view of the electronic circuit device as the first
25 embodiment of the invention.

Fig. 6 is a diagram showing a relationship between a ratio of lead frame width W_1 /substrate width

W2 and a ratio of stress in resin at end of lead frame changing in accordance with a change in ratio of lead frame width W1/substrate width W2 and stress in resin at end of lead frame obtained when lead frame width W1
5 = substrate width W2.

Fig. 7 is a schematic view showing a stress distribution in a comparative sample.

Fig. 8 is a schematic view showing a stress distribution in an embodiment of the invention.

10 Fig. 9 is a lower view of an electronic circuit device as a second embodiment of the invention.

Fig. 10 is a cross sectional front view of the electronic circuit device as the second embodiment taken along a line X-X in Fig. 9.

15 Fig. 11 is a partially cross sectional upper view of the electronic circuit device as the second embodiment.

Fig. 12 is a partially cross sectional front view of the electronic circuit device as the second
20 embodiment

Fig. 13 is a partially cross sectional side view of the electronic circuit device as the second embodiment

Fig. 14 is a lower view of an electronic
25 circuit device as a third embodiment of the invention.

Fig. 15 is a cross sectional front view of the electronic circuit device as the third embodiment taken along a line XV-XV in Fig. 14.

Fig. 16 is a lower view of an electronic circuit device as a fourth embodiment of the invention.

Fig. 17 is a cross sectional front view of the electronic circuit device as the fourth embodiment
5 taken along a line XVII-XVII in Fig. 16.

Fig. 18 is a cross sectional view of an end of substrate.

Fig. 19a is a cross sectional view of an end of a lead frame formed by a shearing process.

10 Fig. 19b is a cross sectional view of an end of a lead frame formed by an etching process.

Fig. 20 is a partially cross sectional upper view of an electronic circuit device as a comparative sample.

15 Fig. 21 is a cross sectional front view of the electronic circuit device as the comparative sample.

Fig. 22 is a partially cross sectional side view of the electronic circuit device as the
20 comparative sample.

Detailed Description of the Invention

In a first embodiment of electronic circuit device as shown in Figs. 1-5, a ceramic substrate 2 on which electronic circuit elements 1 are mounted is
25 adhered to a lead frame 3 by an resin adhesive 12, the electronic circuit elements 1 are electrically connected to metallic leads 4 as the claimed

electrically conductive terminal member through
respective aluminum wires 5, and the electronic circuit
elements 1, substrate 2, a part of the lead frame 3 and
parts of the leads 4 are sealed by a resin 6. Another
5 part of the lead frame 3 projects outward from the
resin 6 in such a manner that a heat energy generated
by the electronic circuit elements 1 is radiated to an
outside of the electronic circuit device through the
metallic lead frame 3. In a cross sectional view such
10 as Figs. 2 and 4 taken along an imaginary plane passing
the substrate 2 and lead frame 3 and extending parallel
to the thickness direction, the substrate extends to
project outward with respect to each end 8 of the lead
frame 3 in a transverse direction perpendicular to the
15 thickness direction while the each end 8 of the lead
frame 3 is covered by the sealing resin.

A part of the lead frame 3 and a part of the
substrate 2 overlapping each other as seen in the
thickness direction are adhered by the resin adhesive
20 12 to each other over the whole of a common area in
which the part of the lead frame 3 and the part of the
substrate 2 overlapping each other as seen in the
thickness direction. A width W_1 of the lead frame 3 in
the transverse direction perpendicular to a lead frame
25 protruding direction in which the lead frame 3 projects
outward from the resin 6 and/or perpendicular to a lead
(electrically conductive terminal member) array
direction in which the leads 4 are juxtaposed is

smaller than a width W_2 of the substrate 2 in the transverse direction, in the common area as seen in the thickness direction. Both an upper end surface of the electronic circuit elements 1 and a lower end surface
5 of the lead frame 3 are contained or covered by the resin 6.

The ceramic substrate 2 has a coefficient of linear expansion of about $7 \times 10^{-6} \text{K}^{-1}$, and the lead frame 3 is a stack of a pair of Cu plates and a low coefficient
10 of linear expansion plate of Invar between the Cu plates and has a coefficient of linear expansion of about $8-10 \times 10^{-6} \text{K}^{-1}$. The resin 6 is an epoxy resin or the like (which resin 6 may include low linear expansion coefficient powder such as SiO_2 powder or the like) with
15 a coefficient of linear expansion of about $15 \times 10^{-6} \text{K}^{-1}$.

A difference in coefficient of linear expansion between the substrate 2 and lead frame 3 is smaller than a difference in coefficient of linear expansion between the substrate 2 and resin 6, and a
20 difference in coefficient of linear expansion between the substrate 2 and lead frame 3 is smaller than a difference in coefficient of linear expansion between the lead frame 3 and resin 6, although these differences are preferably as small as possible to
25 restrain a break between the substrate 2 and lead frame 3 and/or between the lead frame 3 and resin 6. The lead frame 3 is metallic to have a great thermal conductivity for discharging a heat energy generated by

the electronic circuit elements 1 to the outside of the resin 6.

As shown in Figs. 20-22, in a comparative sample, the ceramic substrate 2 on which the electronic
5 circuit elements 1 are mounted is adhered to the lead frame 3 by the resin adhesive 12, the electronic circuit elements 1 are electrically connected to the metallic leads 4 through the aluminum wires 5, and the electronic circuit elements 1, substrate 2, the part of
10 the lead frame 3 and parts of the leads 4 are sealed by the resin 6. The width W1 of the lead frame 3 in the transverse direction is larger than the width W2 of the substrate 2 in the transverse direction. The coefficients of linear expansion of the substrate 2,
15 lead frame 3 and resin 6 of the comparative sample are substantially equal to those of the above described first embodiment.

The lead frame 3 is shaped from a sheet alloy material 7 through an etching process or a shearing
20 process. In Fig. 19a showing the end 8 of the lead frame 3 shaped by the shearing process in which a punching die proceeds from an upper surface to a lower surface of the sheet alloy material 7 in Fig. 19a, a protruding cusp is formed at a lower end edge of the
25 lead frame 3. In Fig. 19b showing the end 8 of the lead frame 3 as the stack of the pair of Cu plates 10 and the Inver plate 11 shaped by the etching process, the protruding cusp is formed at each of lower and

upper end edges of the lead frame 3. The protruding cusp increases a degree of stress concentration so that an occurrence of a break between the lead frame 3 and resin 6 and/or a crack of the resin at the protruding cusp is expedited. Therefore, according to the present invention, a relationship between the substrate and the end 8 of the lead frame 3 restrains the occurrence of the break between the lead frame 3 and resin 6 and/or the crack of the resin at the protruding cusp.

10 In Fig. 6 showing a result of a stress analysis by a finite element method on the first embodiment and comparative sample within a temperature range between -55°C and 150°C while the width W_2 of the substrate 2 is fixed and the width W_1 of the lead frame 15 3 is changed so that a ratio of the width W_1 /the width W_2 is changed, a stress value ratio between a stress value generated at the end 8 of the lead frame 3 obtained at each of ratios of the width W_1 /the width W_2 different from each other and a stress value generated 20 at the end 8 of the lead frame 3 obtained when the ratio of the width W_1 /the width W_2 is 1, that is, the width W_1 = the width W_2 , decreases in accordance with a decrease of ratio between the width W_1 and the width W_2 . From Fig. 6, it is readable that for restraining 25 the occurrence of the break between the lead frame 3 and resin 6 and/or the crack of the resin at the protruding cusp, the ratio of the width W_1 /the width W_2 is preferably less than 1, more preferably not more

than 0.8.

If the electronic circuit elements 1 include a central processing unit (CPU) and/or power transistor generating a large heat energy, it is preferable for
5 restraining the occurrence of the break between the lead frame 3 and resin 6 and/or the crack of the resin at the protruding cusp that as seen in the thickness direction the central processing unit (CPU) and/or power transistor overlaps with the lead frame 3.

10 The ceramic substrate 2 is formed through a green sheet forming process in which a mixture of ceramic material powder and solvent is shaped to a green sheet corresponding to the substrate 2 and a sintering process in which the ceramic material powder
15 is sintered in high temperature. The end 9 of the ceramic substrate 2 does not have the protruding cusp on which the stress concentration occurs so that the occurrence of the break between the substrate 2 and resin 6 and/or the crack of the resin at the end 9 of
20 the substrate 2 is prevented.

As shown in Figs. 7 and 8, a distribution of shearing stress in a width direction parallel to a boundary face between the substrate 2 and lead frame 3 is generated between the resin 6 and each the substrate
25 2 and lead frame 3 in each of the embodiment and comparative sample, because of a significant difference in coefficient of linear expansion therebetween. When a thermal cycle test within the temperature range

between -55°C and 150°C is applied to the embodiment and comparative sample, the shearing stress becomes substantially zero at 150°C because the resin is softened, and the shearing stress becomes significantly
5 great at -55°C , because the coefficient of linear expansion of the resin 6 (contraction rate with respect to temperature decrease) is significantly greater than that of each of the substrate 2 and lead frame 3. In the distribution of shearing stress, the farther a
10 position is from a central position of each of the substrate 2 and lead frame 3 in the width direction, the greater the shearing stress between the resin 6 and each the substrate 2 and lead frame 3 is.

In the comparative sample, as shown in Fig.
15 7, the maximum shearing stress generated at the end 8 of the lead frame 3 in the width direction is greater than the maximum shearing stress generated at the end 9 of the substrate 2 in the width direction. In the embodiment, as shown in Fig. 8, the maximum shearing
20 stress generated at the end 8 of the lead frame 3 in the width direction is smaller than the maximum shearing stress generated at the 9 of the substrate 2 in the width direction. A stress concentration for the shearing stress at the end of one of the lead frame 3
25 and the substrate 2 is restrained when another one of the lead frame 3 and the substrate 2 projects outward in the width direction with respect to the one of the lead frame 3 and the substrate 2, that is, from the end

of the one of the lead frame 3 and the substrate 2, and is decreased by a smooth and round (not cusp shape) corner of the end 9 of the ceramic substrate 2.

Therefore, in accordance with the present invention in which the ceramic substrate 2 projects outward in the width direction from the end 8 of the lead frame 3, the occurrence of the break between the lead frame 3 and resin 6 and/or the crack of the resin 6 at the end 8 of the lead frame 3 is prevented while the occurrence of the break between the substrate 2 and resin 6 and/or the crack of the resin 6 at the end 9 of the substrate 2 is prevented by the smooth and round (not cusp shape) corner of the end 9 of the substrate 2.

In a second embodiment as shown in Figs. 9-13, a width of a part of the lead frame 3 projecting outward from the resin 6 is greater than another part of the lead frame 3 facing to the substrate 2 in the thickness direction and covered by the resin 6, so that a thermal radiation effect from the lead frame 3 to an environment around the device is increased.

In a third embodiment as shown in Figs. 14 and 15, the width of the lead frame 3 increases gradually from the another part thereof to the part thereof so that a stress concentration caused by an abrupt change of the width of the lead frame 3 is prevented.

In a fourth embodiment as shown in Figs. 16 and 17, since the lead frame 3 has a constriction of

width between the another part and the part thereof, a thermal conduction from the part to the another part through the lead frame 3 is decreased by the constriction of width to prevent an abrupt change in temperature of the lead frame 3 so that the crack of the resin 6 adjacent to a boundary between the part of the lead frame 3 and the resin 6 is prevented from being formed by a stress generated by the abrupt change in temperature, that is, in expansion of the lead frame 3, even when the electronic circuit device is electrically connected to a printed board by soldering with increasing abruptly the temperature of the part of the lead frame 3.